

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : S. Yamazaki et al. Art Unit : Unknown
Serial No. : New Div. Application Examiner : Unknown
Filed : August 26, 2003
Title : SEMICONDUCTOR THIN FILM AND ITS MANUFACTURING METHOD
AND SEMICONDUCTOR DEVICE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Prior to examination, please amend the application as indicated on the following pages.

Amendments to the specification begin at page 2 of this paper.

Amendments to the claims are reflected in the listing of claims which begins at page 3 of this paper.

Remarks begin at page 5 of this paper.